

OCT 17 2005

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FACSIMILE COVER SHEET

To: Examiner Alexander O. Williams Technology Center 2800	Total Pages Sent: 2 (including cover sheet)
Facsimile Number: 571-273-8300	Transmission Date: October 17, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Schulze, et al. Docket No.: 115747-0003//
2002P50544US

Serial No: 10/753,604 Art Unit: 2826

Date Filed: January 8, 2004

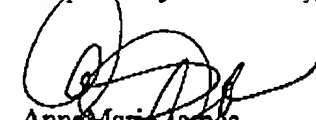
Title: Method for the Repair of Defects in Photolithographic Masks for Patterning
Semiconductor Wafers

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I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 571-273-8300 on the date shown above:

- Certification of Facsimile Transmission (1 page)
- Election (1 page)

Respectfully submitted,


AnneMarie James
Legal Assistant**Confirmation Respectfully Requested**

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Schulze, et al.	Docket No.:	115747-0003// 2002P50544US
Serial No.:	10/753,604	Art Unit:	2826
Filed:	1/8/2004	Examiner:	Alexander O. Williams
Title:	Method for the Repair of Defects in Photolithographic Masks for Patterning Semiconductor Wafers		

Date: October 17, 2005

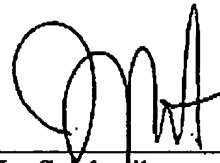
Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

ELECTION

Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed on September 29, 2005, the Applicant hereby elects Group II (claims 1-18 and 29-47) for further prosecution in the above patent application.

Respectfully submitted,



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